INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 4, 2024

IGI Report Number	LG636494209
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	TRAPEZE STEP CUT
Measurements	8.25 X 4.66 X 2.83 MM

GRADING RESULTS

Carat Weight	1.01 CARAT
Color Grade	E
Clarity Grade	VS 1

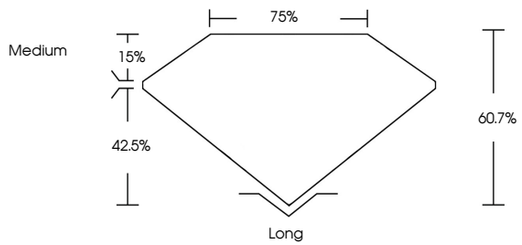
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG636494209

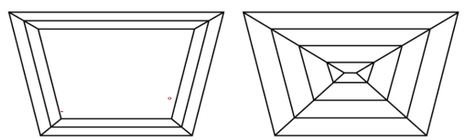
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG636494209
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

www.igi.org

Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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DIAMOND REPORT

June 4, 2024

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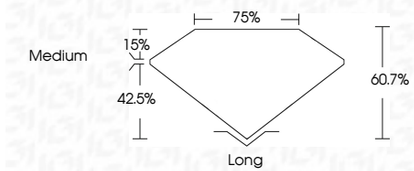

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG636494209

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

June 4, 2024
IGI Report No LG636494209
TRAPEZE STEP CUT
8.25 X 4.66 X 2.83 MM

Carat Weight	1.01 CARAT
Color Grade	E
Clarity Grade	VS 1
Depth	60.7%
Table	75%
Girdle	Medium
Culet	Long
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG636494209

Comments:
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Type IIa